

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)
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 LIOU et al.) Examiner: NADAV, O
)
 Serial No.: 09/467,675) Art Unit: 2811
)
 Filed: Dec. 21, 1999) Docket No.: 252103-4540
)
 For: Structure For ESD Protection With Single)
 Crystal Silicon Sided Junction)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on December 6, 2001.

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PETITIONS OFFICE

Signature – Hui Chin Barnhill

RESPONSE TO OFFICE ACTION

Assistant Commissioner of Patents and Trademarks
Washington, DC 20231

Sir:

The Office Action mailed Aug. 13, 2001 (Paper No. 9), has been carefully considered. In response thereto, please consider the following remarks.

REMARKS

Present Status of the Application

The Office Action rejected all presently-pending claims 1-16 and 18-21. Specifically, the Office Action rejected claims 1-16 and 18-21 under 35 U.S.C. 103(a), as being unpatentable over Yamaguchi et al. (U.S. Patent 6,118,154) in view of Hu et al. (U.S. Patent 6,121,077), Erdeljac et